

Notice of References Cited		Application/Control No. 10/711,967	Applicant(s)/Patent Under Reexamination TAMURA, DEREK	
		Examiner HAO FU	Art Unit 3696	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0123949	09-2002	VanLeeuwen, Michael J.	705/35
*	B	US-2006/0064366	03-2006	Smith, Steven E.	705/035
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

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